OMB No. 0651-0011

INFORMATION DISCLOSURE STATEMENT	Atty. Docket No.: 150.01160102	Serial No.: 10/680,038
	Applicant(s): Eugene P. Marsh	Confirmation No.: 8583
	Application Filing Date: October 7, 2003	Group: ~~2812~~ 2824
	Information Disclosure Statement mailed:	January 13, 2004

U.S. PATENT DOCUMENTS

Examiner Initial	Copy Enclosed	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
CDW		4,423,087	12/27/83	Howard et al.	427	79	
		4,471,405	09/11/84	Howard et al.	361	305	
		5,122,477	06/16/92	Wolters et al.	438	3	
		5,212,620	05/18/93	Evans, Jr. et al.	361	313	
		5,489,548	02/06/96	Nishioka et al.	438	396	
		5,520,992	05/28/96	Douglas et al.	428	209	
		5,554,564	09/10/96	Nishioka et al.	438	396	
		5,572,052	11/05/96	Kashihara et al.	257	295	
		5,605,858	02/25/97	Nishioka et al.	505	330	
		5,612,574	03/18/97	Summerfelt et al.	257	783	
		5,753,945	05/19/98	Chivukula et al.	257	295	
		5,969,419	10/19/99	Tijburg et al.	257	753	
		5,990,559	11/23/99	Marsh	257	768	
		6,001,461	12/14/99	Toyoda et al.	428	210	
		6,244,575	06/12/01	Vaartstra	261	141	
		6,402,126	06/11/02	Vaartstra	261	141	
CDW		6,642,567	11/04/03	Marsh	257	306	

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Examiner Initial	Copy Enclosed	Document Number	Date	Country	Class	Subclass	Translation Yes	Translation No
CDW		EP 0 618 597 A1	10/05/94	Europe				
		EP 0 697 717 A1	02/21/96	Europe				
		EP 0 697 718 A1	02/21/96	Europe				
CDW		EP 0795 896 A2	09/17/97	Europe				

EXAMINER	Date Considered
Christian Wilson	3/17/04

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OMB No. 0651-0031

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CDW		JP 9 51079	02/1997	Japan				

OTHER DOCUMENTS (Including Authors, Title, Date, Pertinent Papers, etc.)

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		Kravchuk et al., "Formation and physicochemical properties of Pt/ZeO_2 catalyst," *Zhurnal Prikladnoj Khimii*, 1995;68(*12*): 2009-2012. (English Abstract Only)
		Niemer et al., "Organometallic chemical vapor deposition of tungsten metal and suppression of carbon incorporation by codeposition of platinum," *Appl. Phys. Lett.*, 1992;61(*15*): 1793-1795.
		Pathangey et al., "Atomic Layer Deposition for Nanoscal Thin Film Coating," *Vacuum Technology and Coating*, May 2000: 32-41.
		Takasu et al., "Preparation of a novel Pt-RuO_2/Ti electrocatalyst by use of highly porous ruthenium oxide support prepared from RuO_2-La_2O_3/electrode," *Journal of Alloys and Compounds*, 1997;261: 172-175.
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		~~Precious Metal Labware Catalog from Alfa Aesar, 6 pgs.~~

EXAMINER	Date Considered
Christian C. Wilson	3/17/04

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